

2016 Editorial Calendar

July • August

TSV metals market update	ICEPT 2016 Wuhan, China (Aug 16-19) SEMICON Taiwan Taipei, Taiwan (Sept 7-9) BiTS China 2016 Suzhou, China (Sept 13) MEPTEC Medical Electronics Symposium Portland, OR (Sept 14-16) SEMI European MEMS Summit Stuttgart, Germany (Sept 15-16)
Bonding/debonding for heterogeneous integration	
Photonics packaging	
Packaging for power devices	
Advances in MEMS packaging	
Solder reliability	
Materials development of SiP & IoT	

International Directory of Bonding Equipment for 2.5D and 3D Assembly

Ad Space Close Jun 24 - Ad Materials Close Jul 1

September • October	
Lithography for advanced packaging	• IMAPS 2016 Pasadena, CA (Oct 11-13) • ICPT 2016 Beijing, China (Oct 17-19) • IWLPC-International Wafer-Level Packaging Conference & Exhibition San Jose, CA (Oct 18-20) • SEMICON Europa Grenoble, France (Oct 25-27)
Panel-level packaging	
Trends in TSV technologies	
WLP challenges for MEMS	
Flip-chip packaging	
SiPs	
Cost modeling	

Ad Space Close Sep 9 - Ad Materials Close Sep 16

November • December 3D TSVs MEMS Executive Congress Scottsdale, AZ (Nov 10-11) • SEMICON Japan Recent advances in 3D package reliability Tokyo, Japan (Dec 14-16) International Test Conference (ITC) Die stacking Fort Worth, TX (Nov 15-17) • RTI 3D ASIP Conference Heterogeneous integration Redwood City, CA (Dec 15-17) **FOWLP** Failure analysis Thermal management of ICs Materials for test sockets MEMS & sensor technologies

Ad Space Close Nov 4 - Materials Close Nov 11